

FORM PTO-1449

INFORMATION DISCLOSURE CITATION

#2

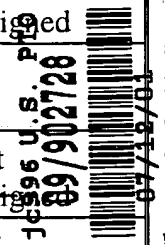
Atty Docket
0140/00272

Serial No.
~~To be assigned~~

Applicant
Arpan P. Mahorowala

Filing Date 7/12/01
Herewith

Group Art Unit
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U.S. PATENT DOCUMENTS

Examiner Initial		Document Number	Date	Name	Class	Sub-Class	Filing Date
	AA						
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						

FOREIGN PATENT DOCUMENTS

		Document Number	Date	Country	Class	Sub-Class	Translation
	AL						Yes No
	AM						Yes No
	AN						Yes No
	AO						Yes No
	AP						Yes No

OTHER (Including Author, Title, Date, Pertinent Pages, etc.)

hly	AR		Pattern Collapse in the Top Surface Imaging Process After Dry Development; Shigeyasu Mori, et al.; J. Vac. Sci. Technol. B 16(6); pp. 3744-3747 (Nov/Dec 1998)
	AS		
	AT		

Examiner *W. W. Hansen*

Date Considered 5/28/03

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP § 600. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant(s).